

Notice of References Cited		Application/Control No. 10/533,677	Applicant(s)/Patent Under Reexamination DE LUCA ET AL.	
		Examiner JEONG S. PARK	Art Unit 2454	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2002/0143961	10-2002	Siegel et al.	709/229
*	C	US-2003/0065662	04-2003	Cosic, Jasmin	707/9
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))
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